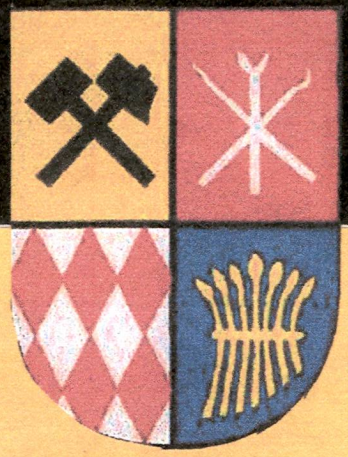

MI-Anlage